

Docket No.: 49657-961



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Kenji ITOGA, et al. : Confirmation Number: 5521
Serial No.: 09/769,490 : Group Art Unit: 2882
Filed: January 26, 2001 : Examiner: C. Kao
For: X-RAY EXPOSURE APPARATUS, X-RAY EXPOSURE METHOD, X-RAY MASK, X-RAY MIRROR, SYNCHROTRON RADIATION APPARATUS, SYNCHROTRON RADIATION METHOD AND SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


It is respectfully requested that the time for response to the Office Action dated April 13, 2004, now due to expire July 13, 2004, be extended for one (1) month and set to expire on August 13, 2004.

Please charge the extension fee of \$110.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

08/13/2004 EABUBAK1 00000121 500417 09769490
02 FC:1251 110.00 DA

Respectfully submitted,

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Date: August 12, 2004